

Mixed irradiation studies with magnetic czochralski diodes

15th RD50 Workshop

Robert Eber

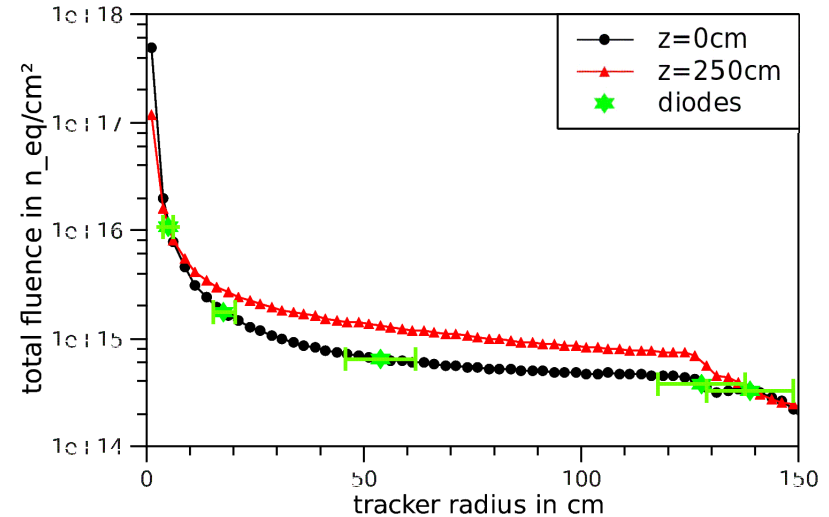
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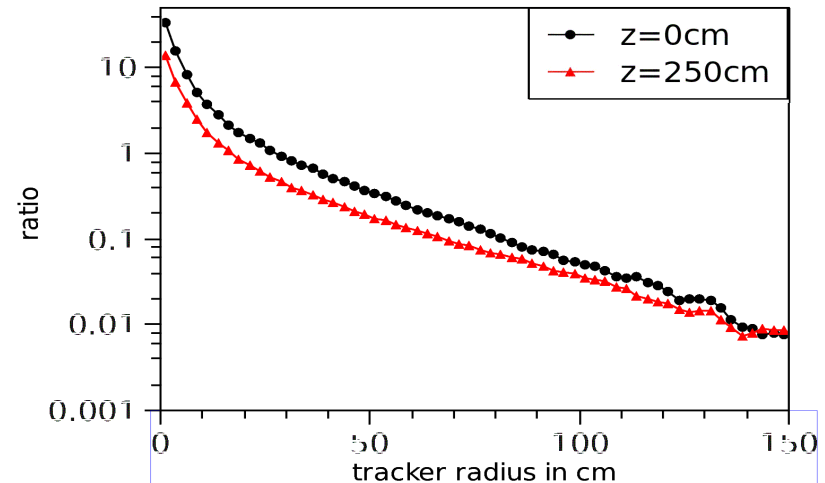
- Irradiation
 - Neutrons at Louvain-la-Neuve
 - Protons at Karlsruhe (25Mev, $k=1.85$)
- IV/CV measurements
 - Probestation Karlsruhe: before irradiation, after each irradiation step
- Annealing steps
 - Initial: 40h at room temperature
 - 4h – 14h at 40°C
- TCT
 - TCT-Setup at Karlsruhe: red Laser (678nm), max. voltage 1100V,
 - Cooling to -190°C
- Measurements: 0 – 1000V, -40°C – 0°C, 2°C steps
- Name of diodes indicates important parameters
- MCz-n_<fluence>-A/B MCz-p_<fluence>_spray/stop

- Magnetic Czochralski silicon diodes from HIP
- 300 μm thick
- 10 n-type diodes
- 10 p-type diodes
- Mixed irradiation with
 - 1. neutrons
 - 2. protons
- Ratio of charged hadrons to neutral hadrons as expected in the CMS tracker at the sLHC

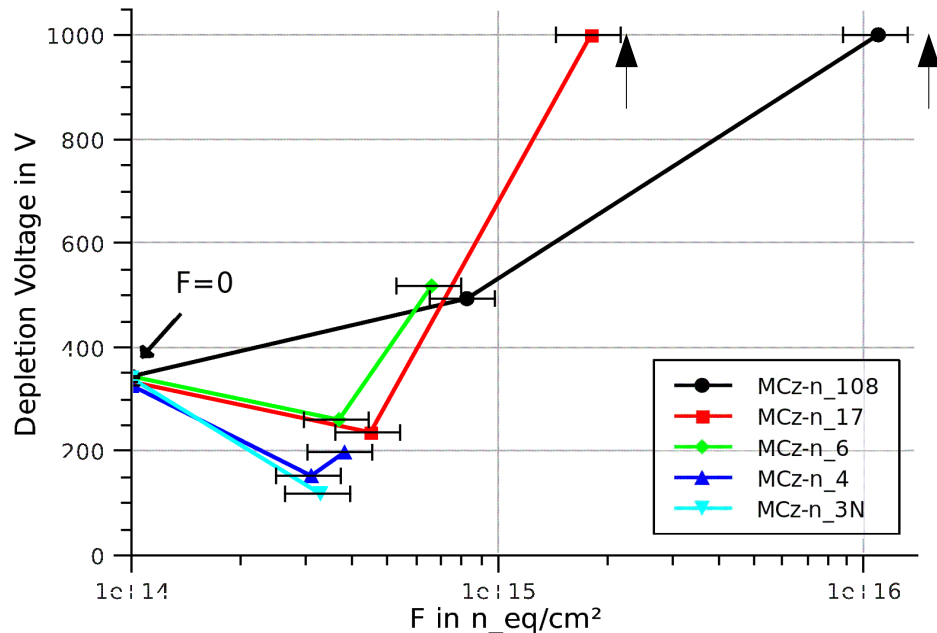
Total fluence in the CMS tracker at sLHC
diodes' fluences



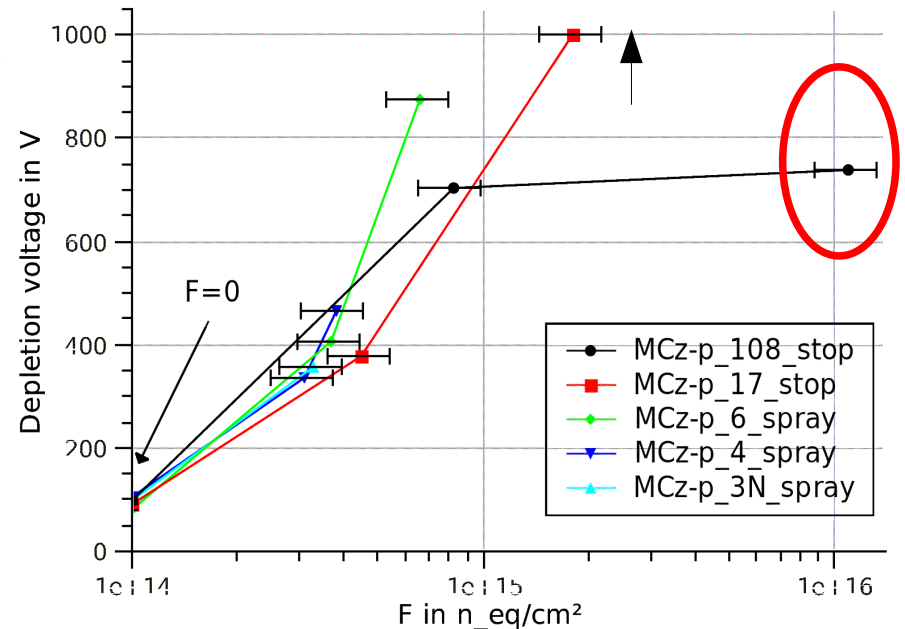
Expected ratio of charged hadrons to neutral hadrons



Depletion voltage n-type diodes



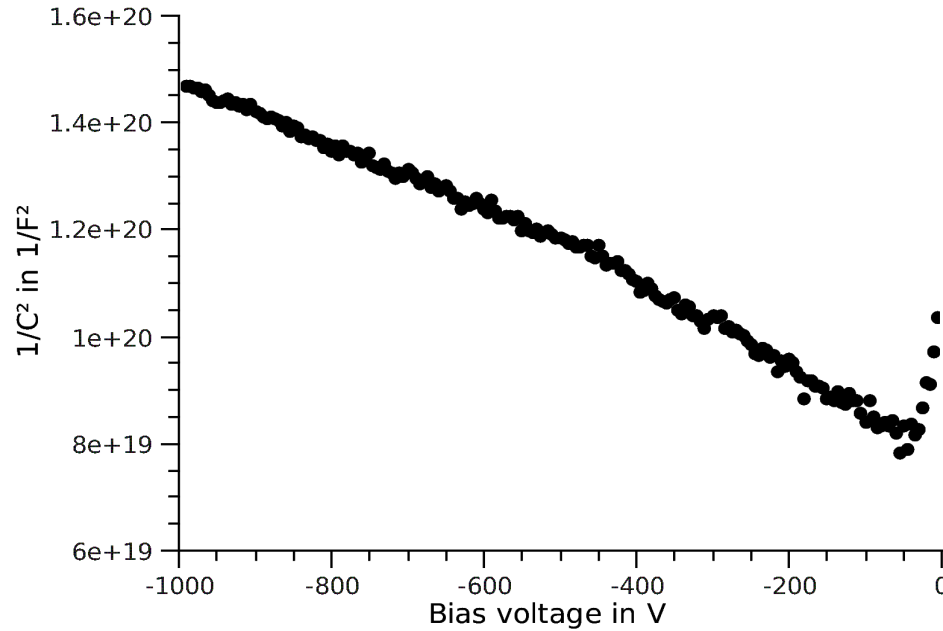
Depletion voltage p-type diodes



- Depletion voltage extracted from CV curves
- CV measurements at $T = -20^\circ\text{C}$, frequency 1kHz
- Only n-type diodes show type inversion
- Annealing time: 40h at room temperature

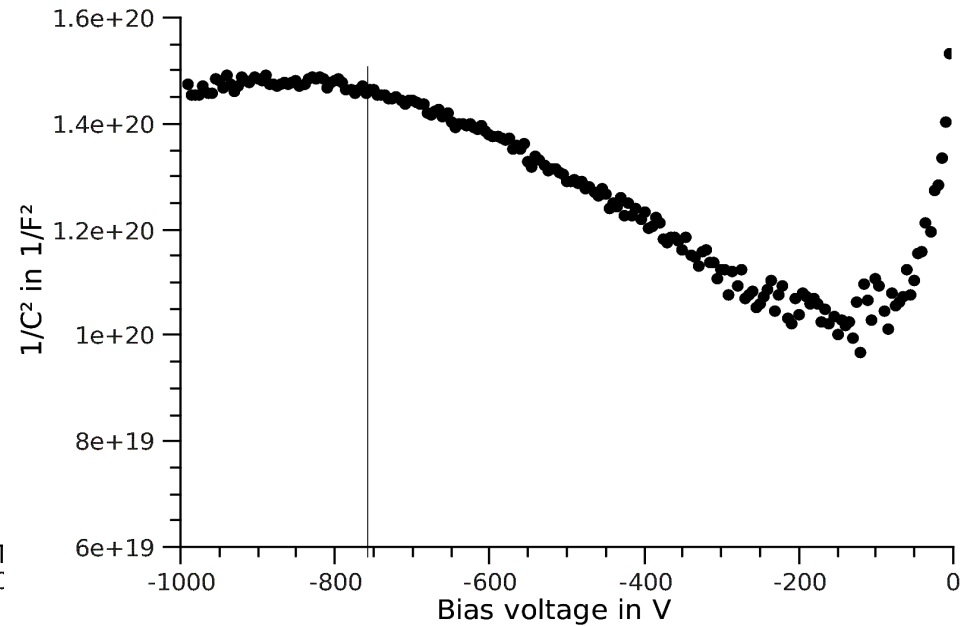
CV-Curves

MCz-p_17_stop, -20°C, 1kHz



$F = 1,7 \cdot 10^{15} \text{ n/cm}^2$
 $V_{\text{dep}} > 1000\text{V}$

MCz-p_108_stop, -20°C, 1kHz



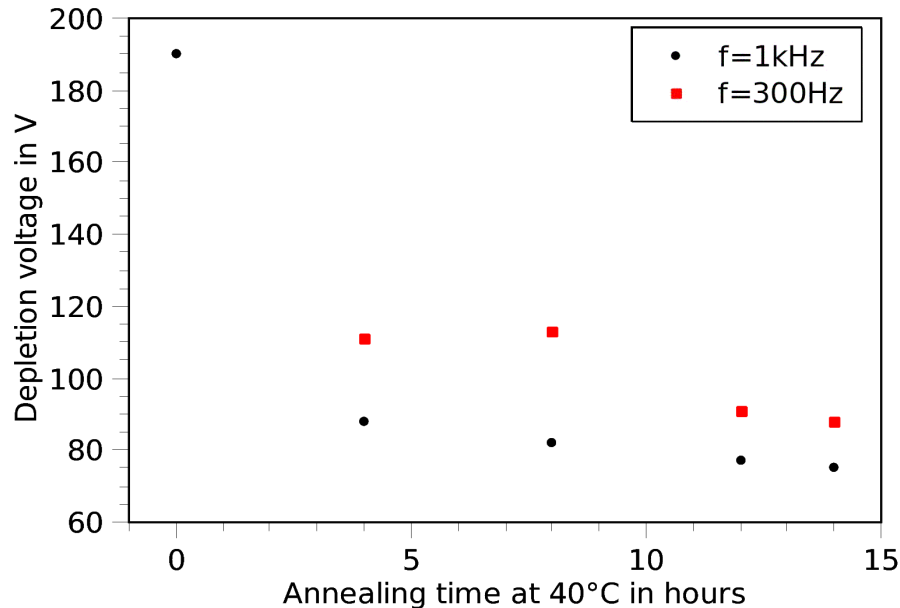
$F = 1,08 \cdot 10^{16} \text{ n/cm}^2$
 $V_{\text{dep}} \sim 750\text{V}$

TCT: no depletion till 1000V

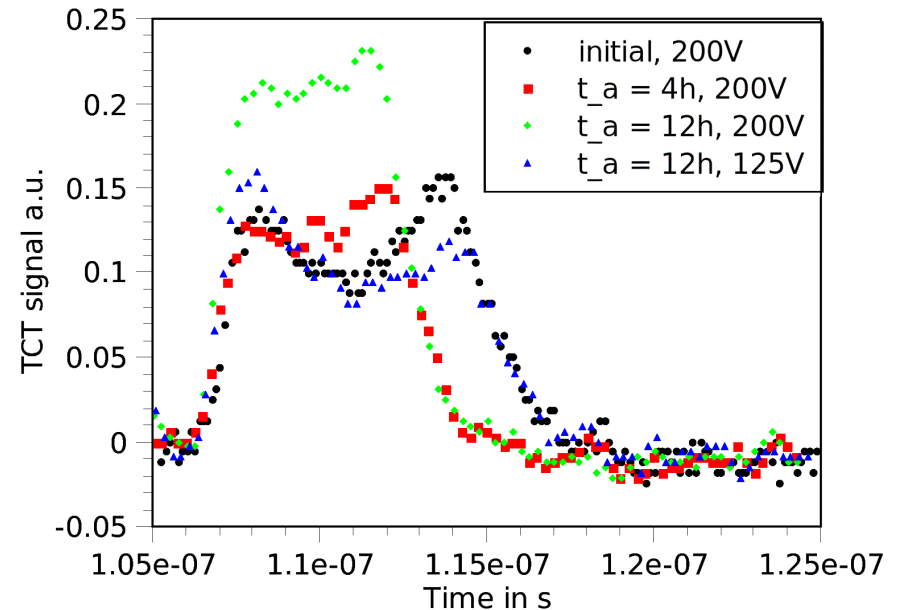
Depletion voltage after annealing

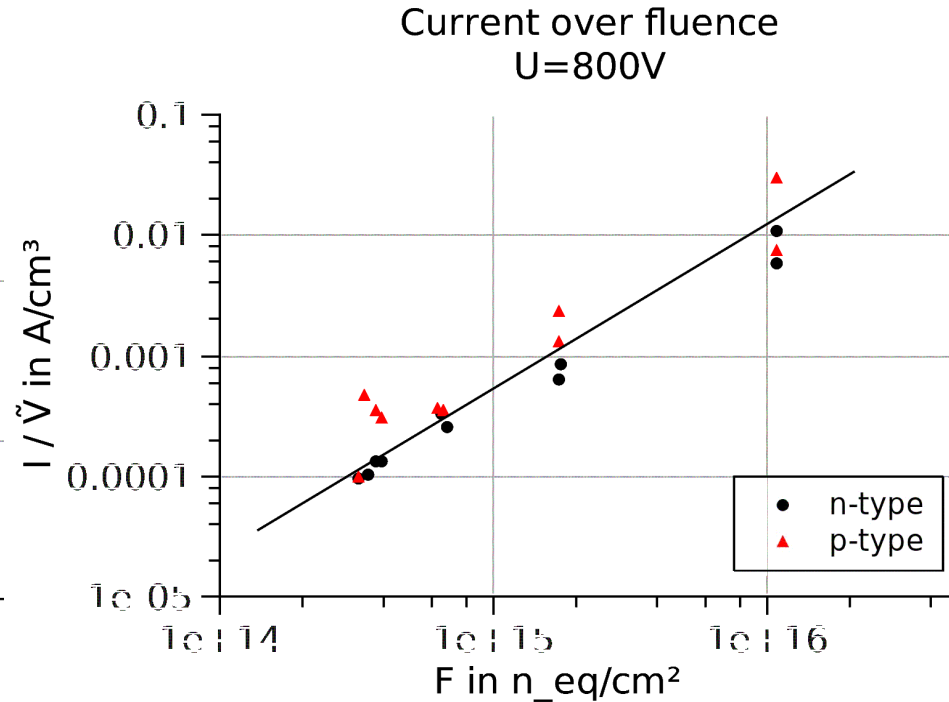
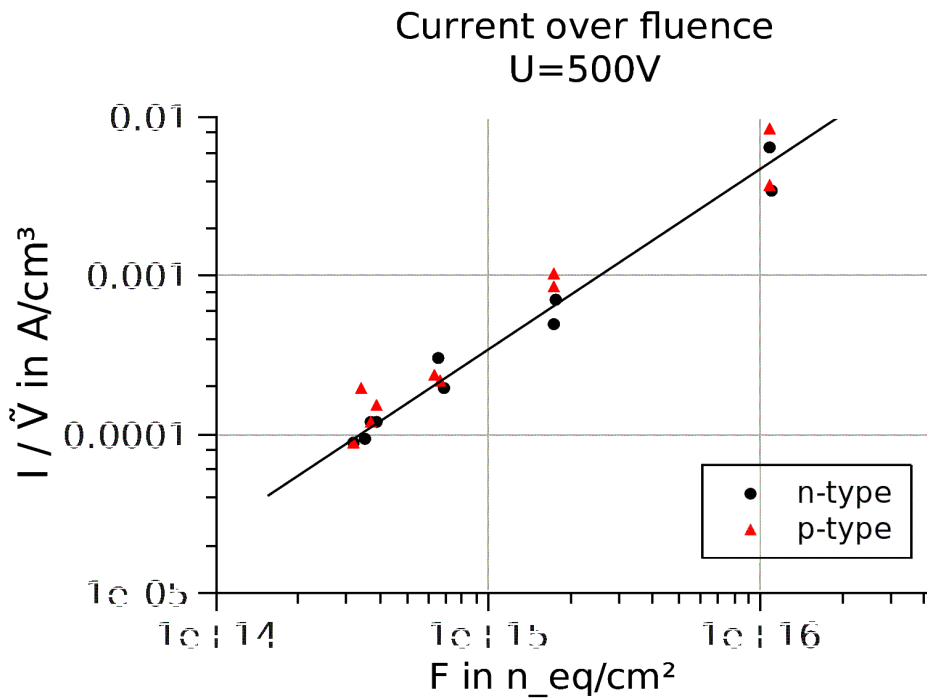
- Annealing at 40°C
- Depletion voltage obtained from CV measurements

Depletion voltage after annealing



TCT signal after annealing, MCz-n_4-A





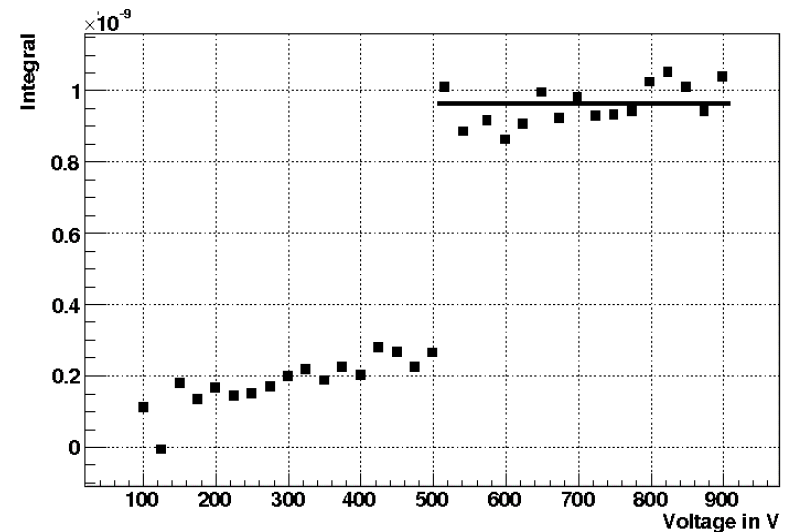
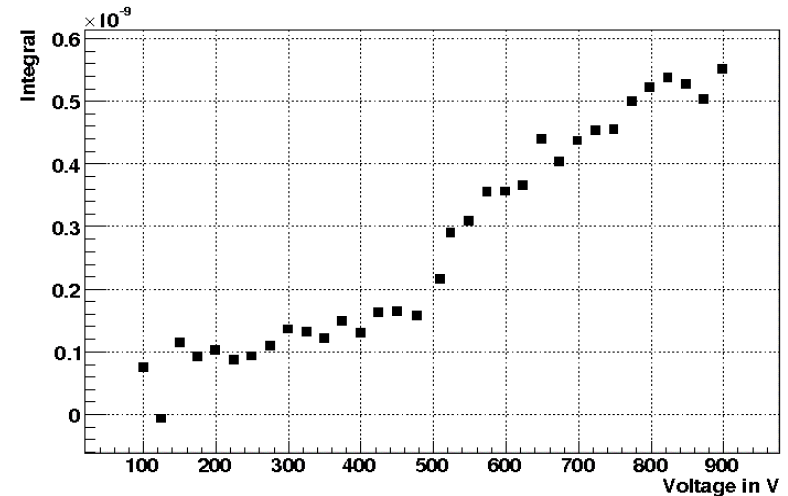
- P-type diodes at $3-4 \cdot 10^{14}$ n/cm² have seen more fluence than expected
- Fluence varying with position at irradiation
- $\alpha = (5.7 \pm 1.1) \cdot 10^{-17}$ A/cm
- Expect $\alpha \sim 6 \cdot 10^{-17}$ A/cm for 48h at 21°C

Method to determine trapping times

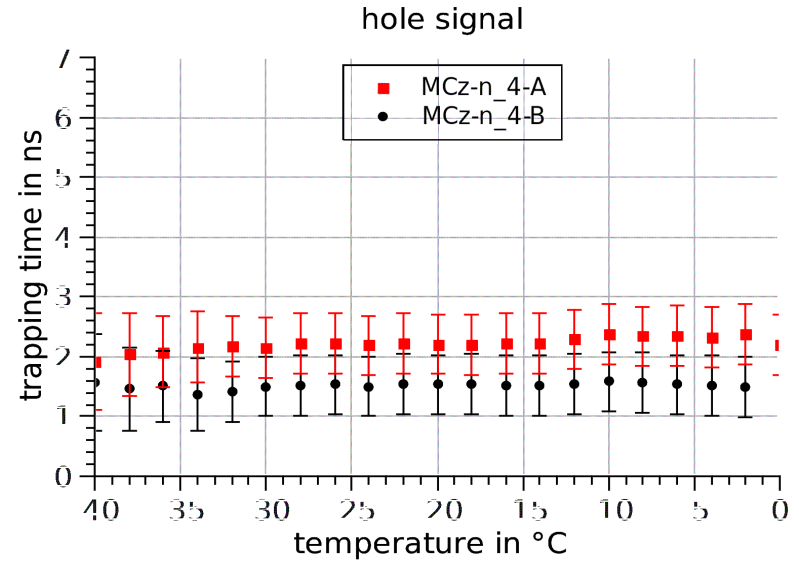
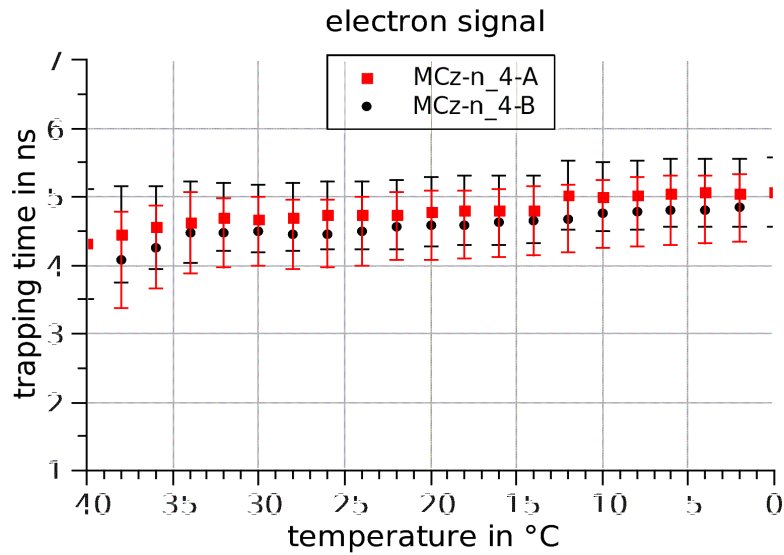
- Correct measured signal with varying trapping times

$$I = I_{meas} * e^{t/t_{trap}}$$

- Above depletion voltage, CCE is constant
- Need datapoints above V_{dep} !
- Fit linear slope
- Find trapping time when slope=0
- Errors:
 - Depletion voltage not exactly known
 - Fit linear slope with $V_{dep} \pm 25V$



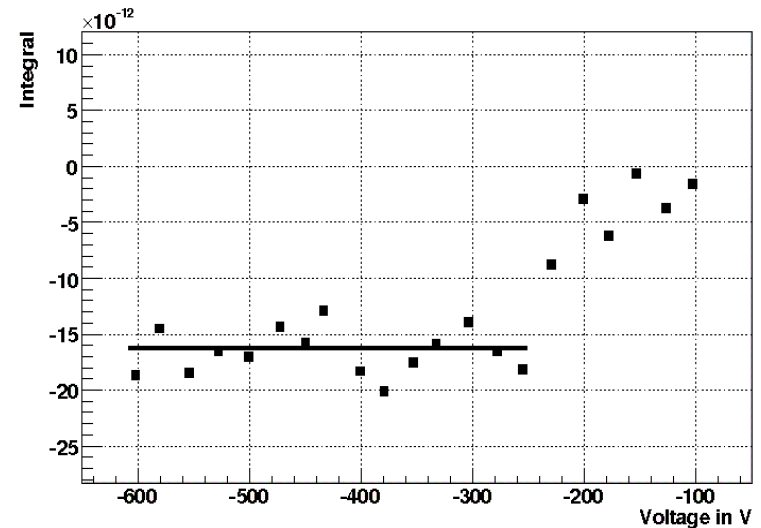
Trapping times n-type diodes



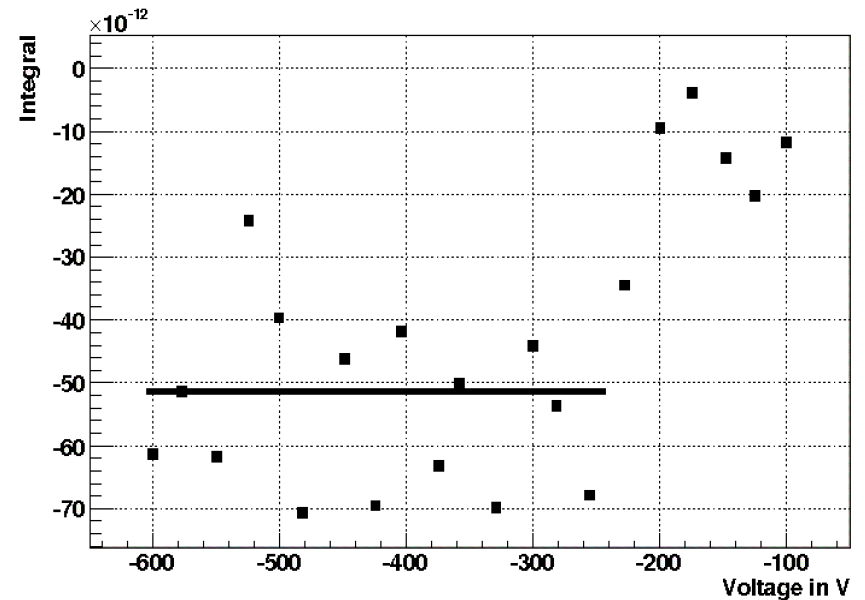
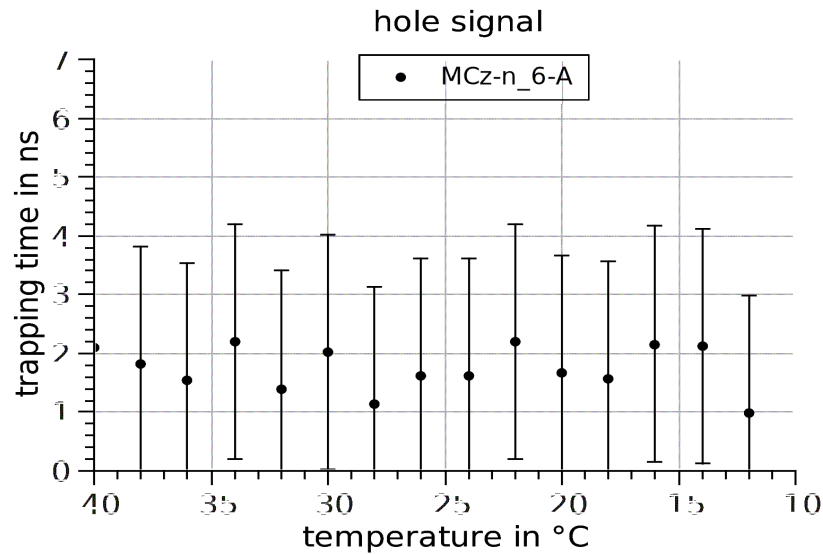
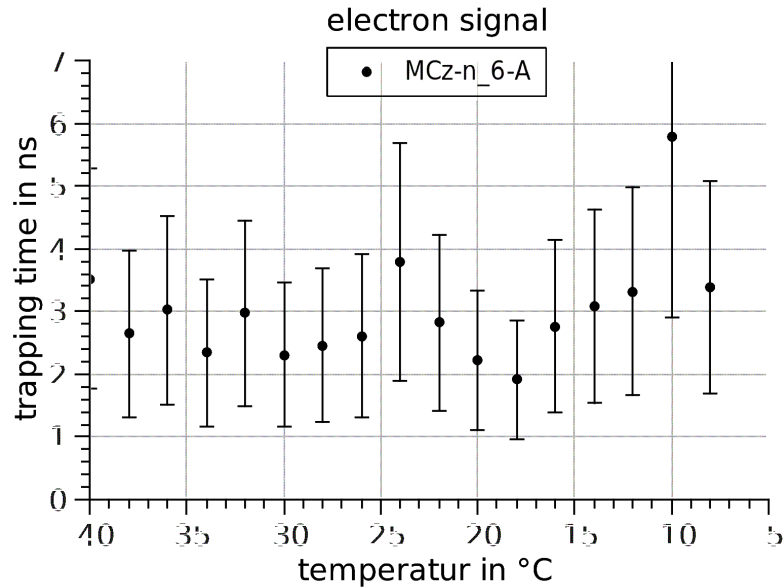
A:F=3.7*10¹⁴n/cm²

B:F=3.9*10¹⁴n/cm²

Protons and neutrons



Trapping times n-type $F=6.5 \cdot 10^{14}$ n/cm²

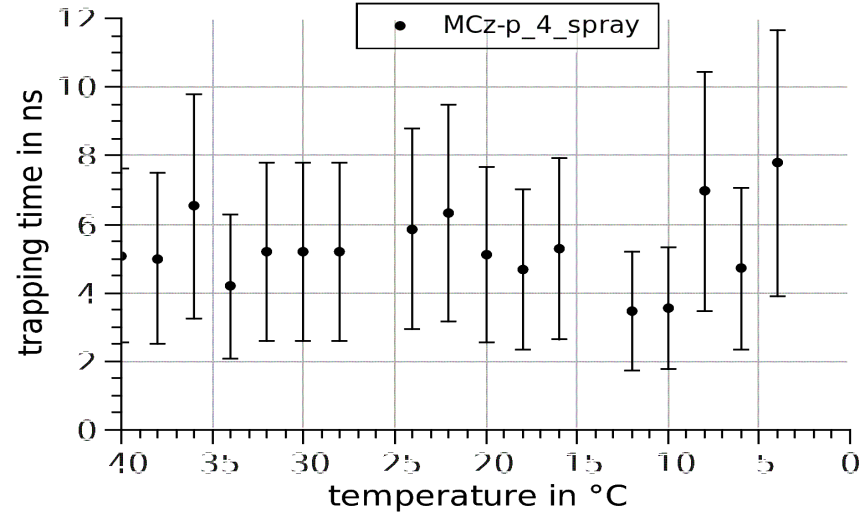


Trapping times p-type diodes

$F=3.7 \cdot 10^{14} \text{ n/cm}^2$

electron signal

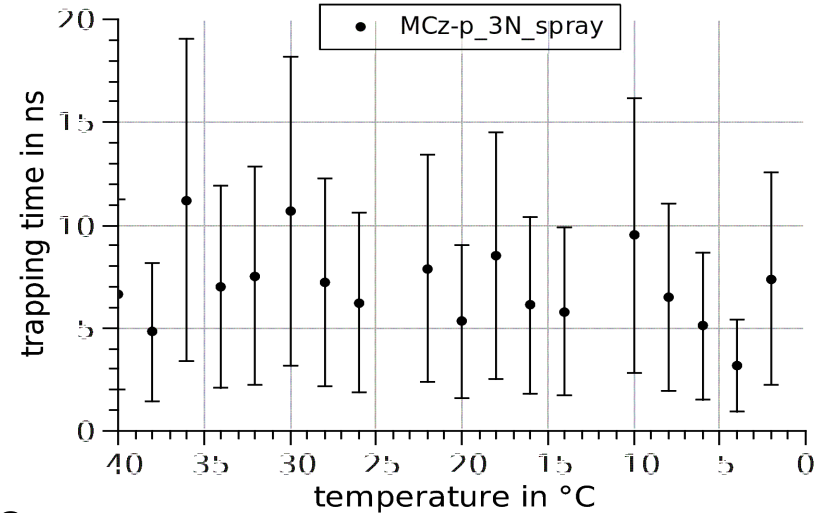
• MCz-p_4_spray



$F=3.2 \cdot 10^{14} \text{ n/cm}^2$

electron signal

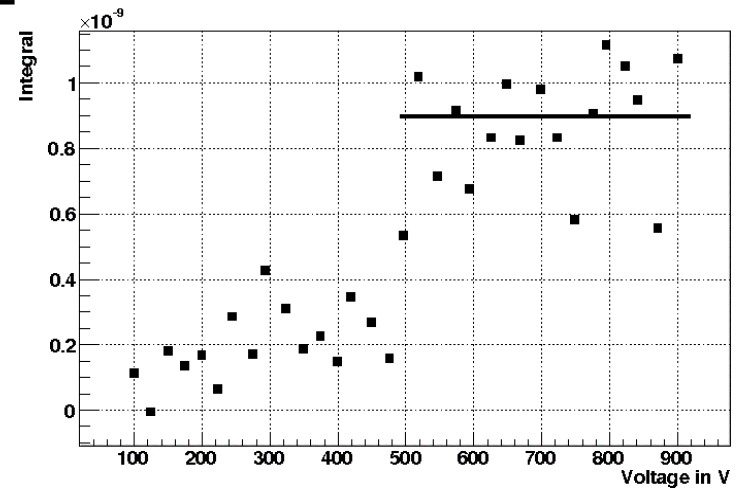
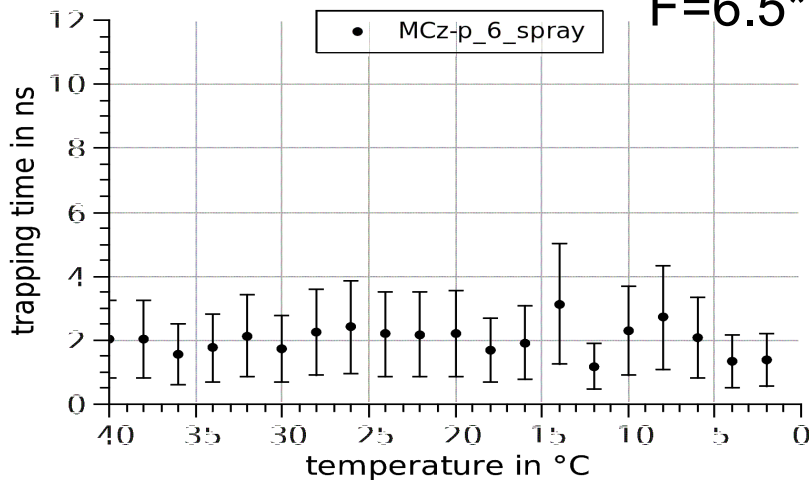
• MCz-p_3N_spray



electron signal

• MCz-p_6_spray

$F=6.5 \cdot 10^{14} \text{ n/cm}^2$



Overview:

Diode	$F_{eq}(n) \left[\frac{n_{eq}}{cm^2} \right]$	$F_{eq}(p) \left[\frac{n_{eq}}{cm^2} \right]$	$\tau_e [ns]$	$\tau_h [ns]$	$\beta'_e \left[\frac{cm^2}{ns} \right]$	$\beta'_h \left[\frac{cm^2}{ns} \right]$
MCz-n_3N-A	$3,2 \cdot 10^{14}$	-	$5,96 \pm 0,7$	$2,87 \pm 0,8$	$5,2 \cdot 10^{-16}$	$10,8 \cdot 10^{-16}$
MCz-n_3N-B	$3,5 \cdot 10^{14}$	-	$5,40 \pm 0,6$	$1,21 \pm 1,0$	$5,3 \cdot 10^{-16}$	$23,6 \cdot 10^{-16}$
MCz-n_4-A	$3,3 \cdot 10^{14}$	$6,8 \cdot 10^{13}$	$4,92 \pm 0,5$	$2,2 \pm 0,5$	$5,2 \cdot 10^{-16}$	$11,6 \cdot 10^{-16}$
MCz-n_4-B	$3,0 \cdot 10^{14}$	$6,8 \cdot 10^{13}$	$4,44 \pm 0,5$	$1,51 \pm 0,6$	$6,1 \cdot 10^{-16}$	$17,9 \cdot 10^{-16}$
MCz-n_6-A	$3,6 \cdot 10^{14}$	$2,9 \cdot 10^{14}$	$3,00 \pm 1,5$	$1,74 \pm 2,0$	$5,1 \cdot 10^{-16}$	$8,84 \cdot 10^{-16}$
MCz-n_17-A	$4,4 \cdot 10^{14}$	$1,3 \cdot 10^{15}$	-	-	-	-
MCz-n_108-A	$8,1 \cdot 10^{14}$	$1,0 \cdot 10^{16}$	-	-	-	-

Diode	$F_{eq}(n) \left[\frac{n_{eq}}{cm^2} \right]$	$F_{eq}(p) \left[\frac{n_{eq}}{cm^2} \right]$	$\tau_e [ns]$	$\tau_h [ns]$	$\beta'_e \left[\frac{cm^2}{ns} \right]$	$\beta'_h \left[\frac{cm^2}{ns} \right]$
MCz-p_3N_spray	$3,2 \cdot 10^{14}$	-	$6,7 \pm 2,6$	$1,8 \pm 1,9$	$4,7 \cdot 10^{-16}$	$17,4 \cdot 10^{-16}$
MCz-p_4_spray	$3,1 \cdot 10^{14}$	$6,8 \cdot 10^{13}$	$5,3 \pm 4,9$	$5,7 \pm 4,0$	$5,1 \cdot 10^{-16}$	$4,7 \cdot 10^{-16}$
MCz-p_6_spray	$3,7 \cdot 10^{14}$	$2,9 \cdot 10^{14}$	$2,3 \pm 1,2$	$2,2 \pm 2,2$	$6,6 \cdot 10^{-16}$	$6,9 \cdot 10^{-16}$
MCz-p_17_stop	$4,5 \cdot 10^{14}$	$1,3 \cdot 10^{15}$	-	-	-	-
MCz-p_108_stop	$7,4 \cdot 10^{14}$	$1,0 \cdot 10^{16}$	-	-	-	-

Comparison for β :

$$\beta_e = 4,1 - 5,7 \cdot 10^{-16} \text{ cm}^2/\text{ns}$$

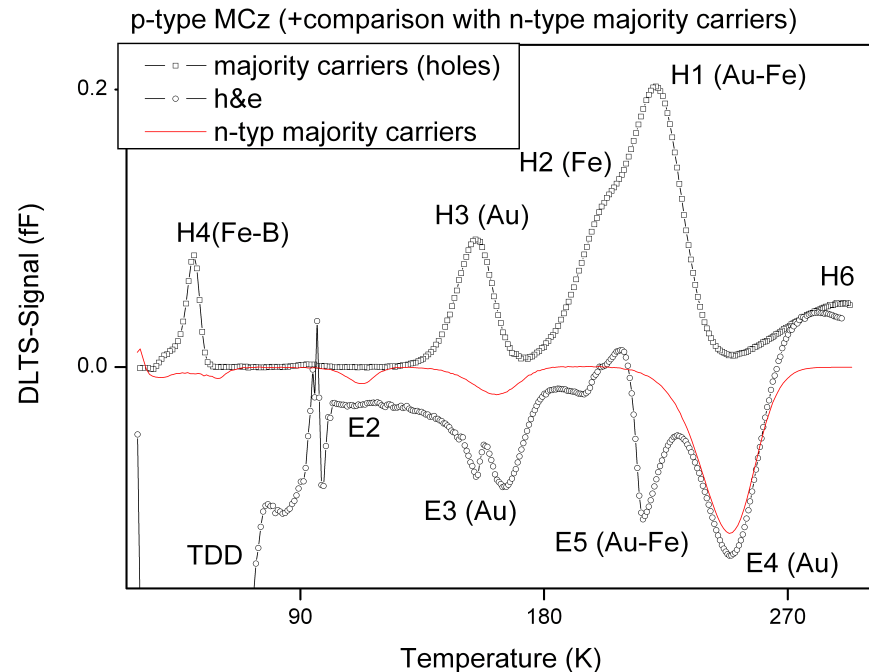
$$\beta_h = 6,0 - 7,7 \cdot 10^{-16} \text{ cm}^2/\text{ns}$$

$$1/\tau = \beta * F$$

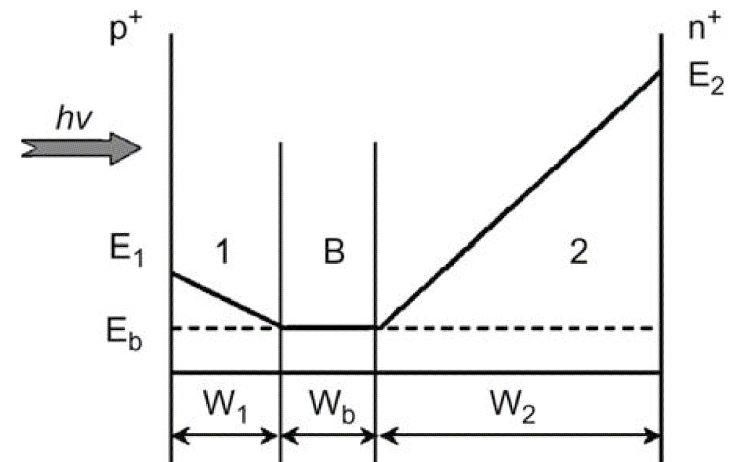
Diodes $F > 10^{15} \text{ n/cm}^2$

- Depletion voltage $> 1000V$
- Trapping times could not be extracted

- DLTS with unirradiated diodes in Hamburg (A. Junkes)
- Impurities in silicon lead to recombination of charge carriers - trapping
- Impurities come from metal
- Diverse possible impurities – assignment difficult
- Gold is a good candidate
- Some defects are introduced during the production of MCz silicon (traps E1 – E4, n-type and p-type)
- E5 only visible in p-type silicon, defects introduced while processing of diodes

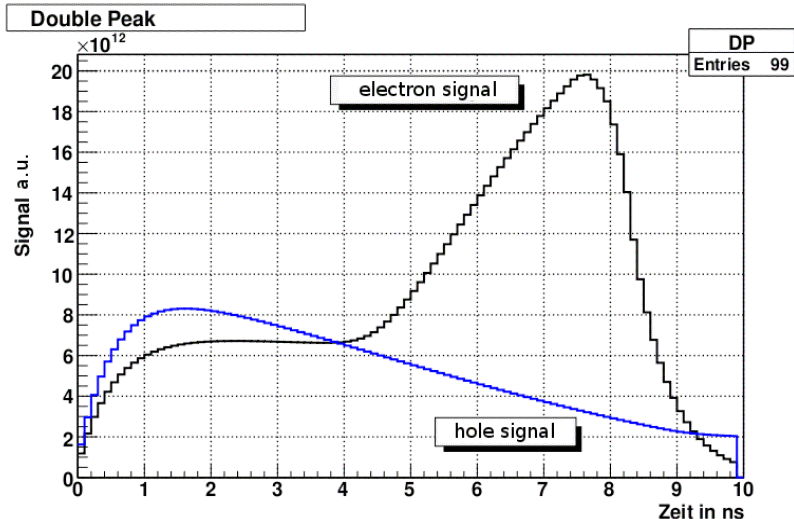
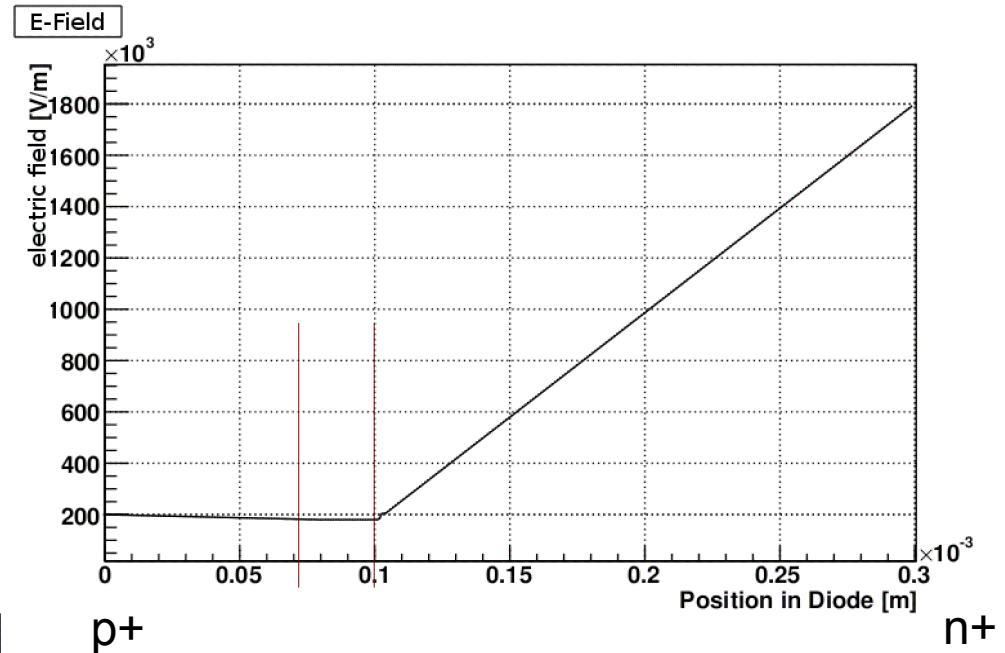
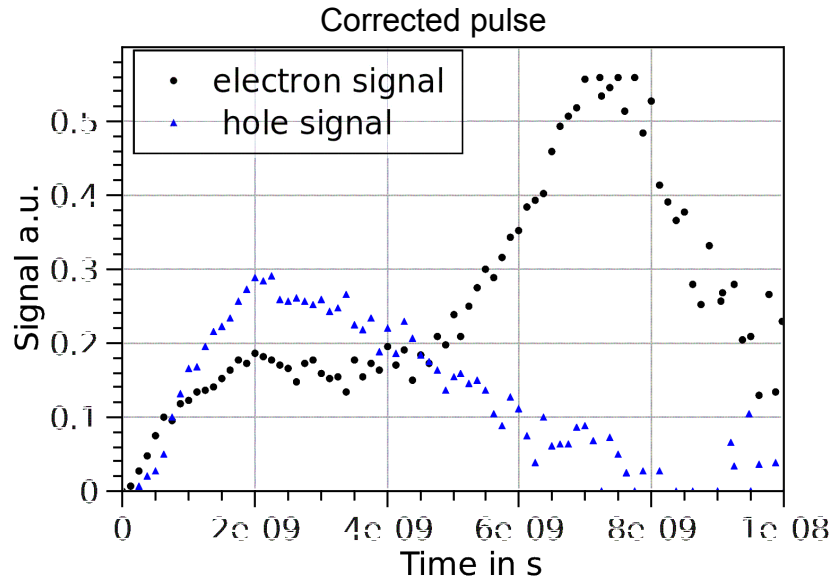


- Simulated transient current through diode
 - Electric field as input parameter
 - Other parameters:
 - saturation drift velocity
 - charge generation depth
 - Diode thickness
 - Methode from Verbitskaya et al.
 - Fit simulated signal to measured signal
 - Reconstruction of electric field in the diode possible
- Used signals at -20°C
 - Diode MCz-n_4-A at 200V / 400V



Verbitskaya et al.

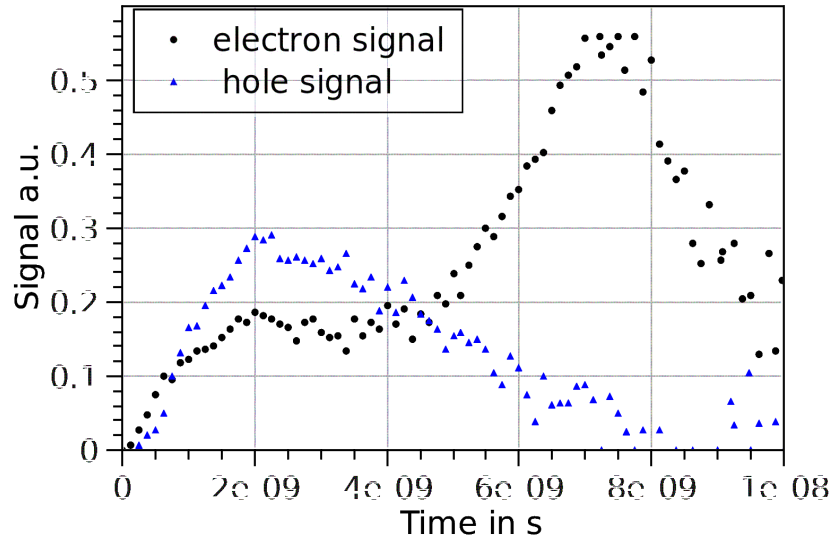
Adjustment of electric field



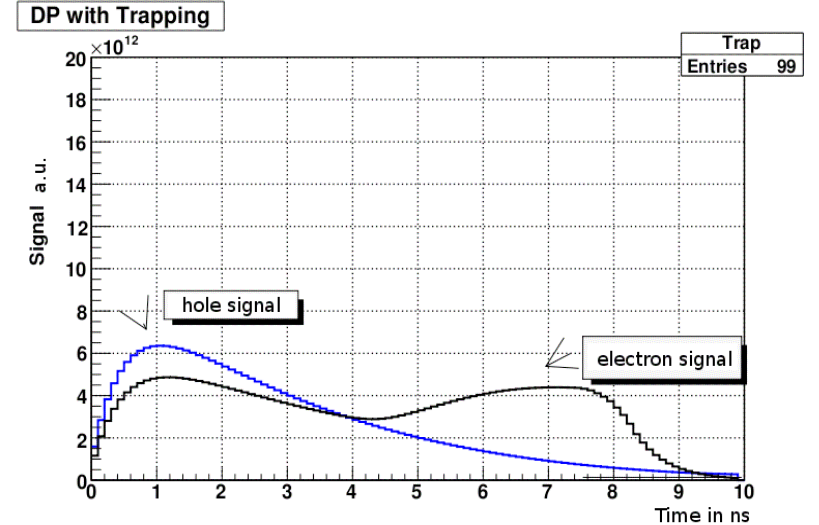
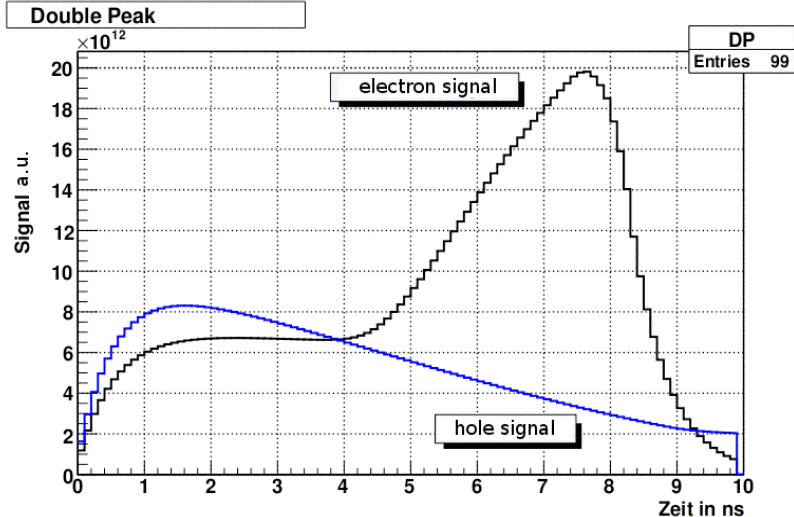
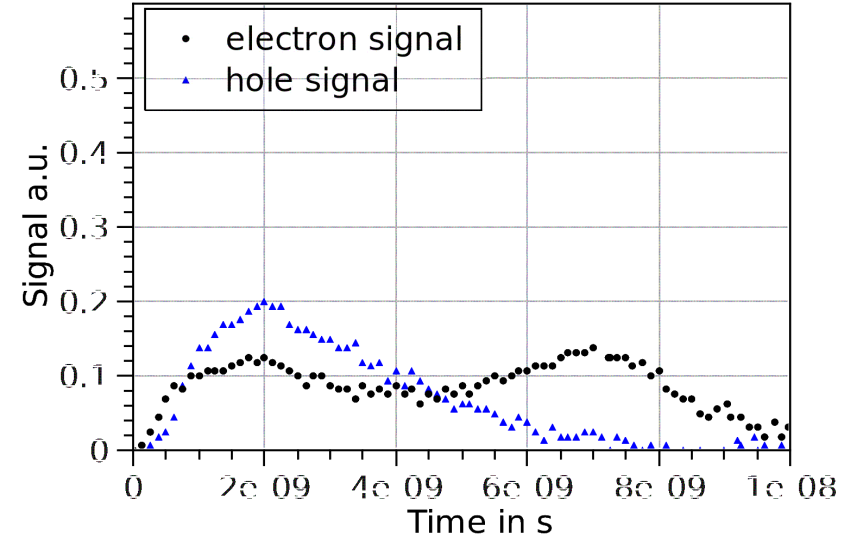
- Use information from both type of charge carriers
- Correct measured signal with trapping time
- $V=200V$, $V_{dep} \sim 150V$

Electric field in the diode, 200V

corrected puls

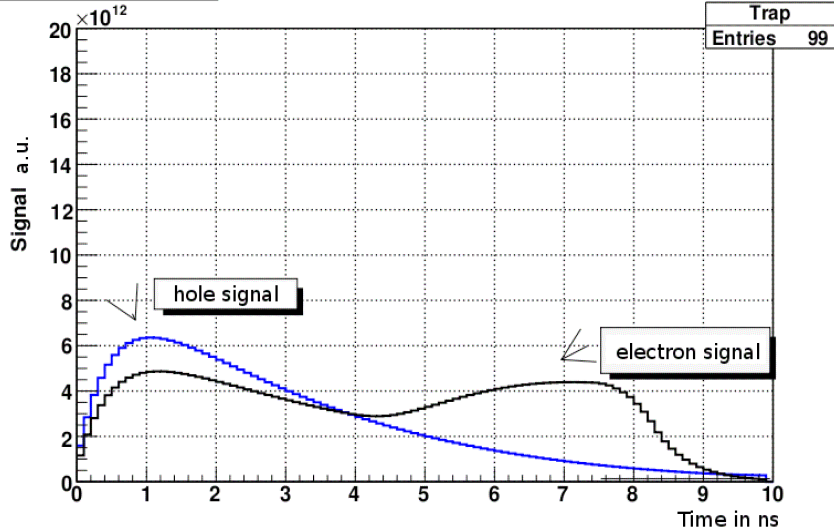


measured puls

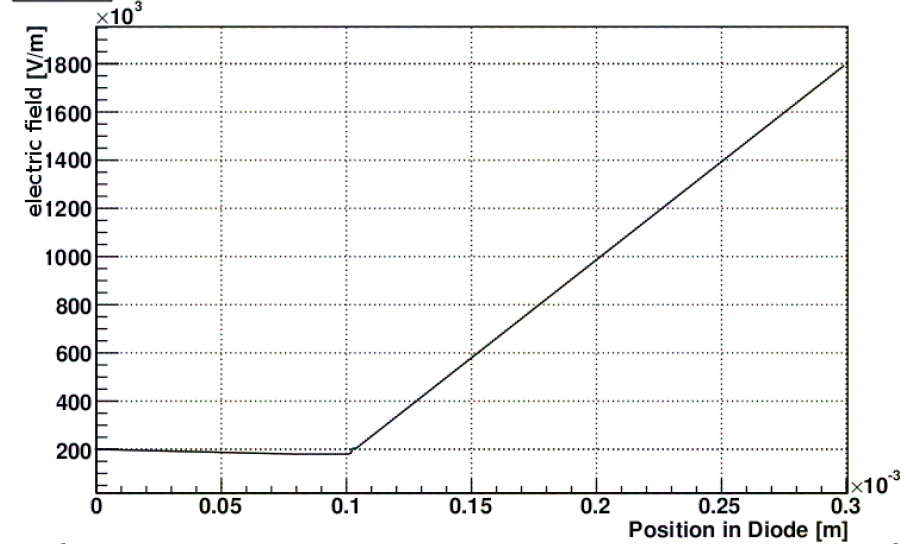


Changing the electric field, 200V

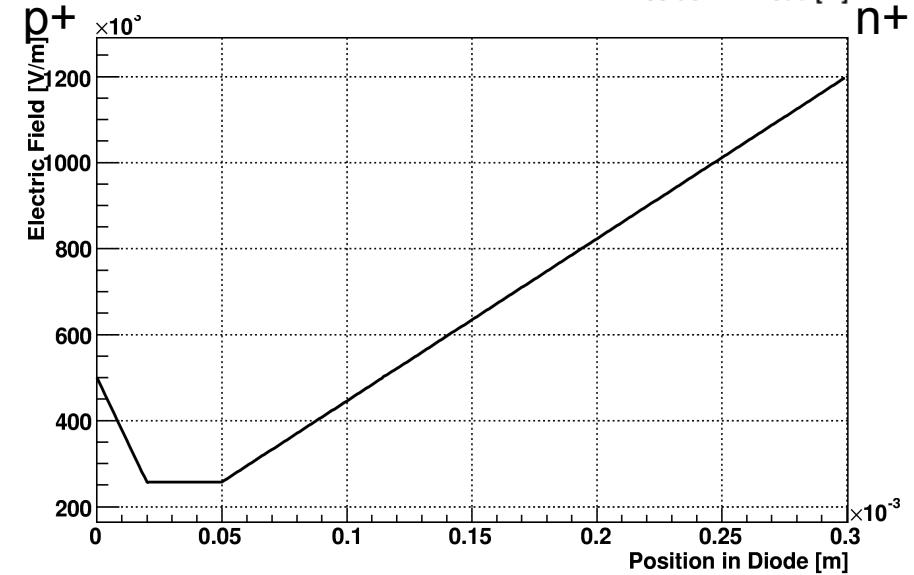
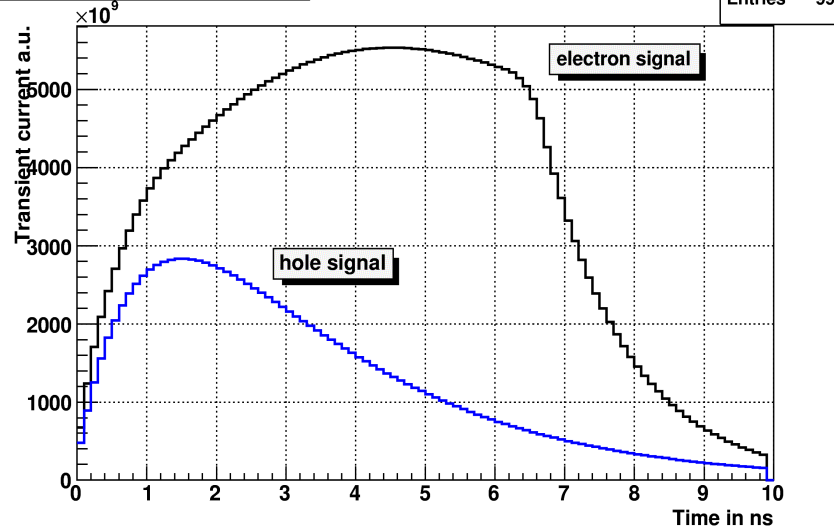
DP with Trapping



E-Field

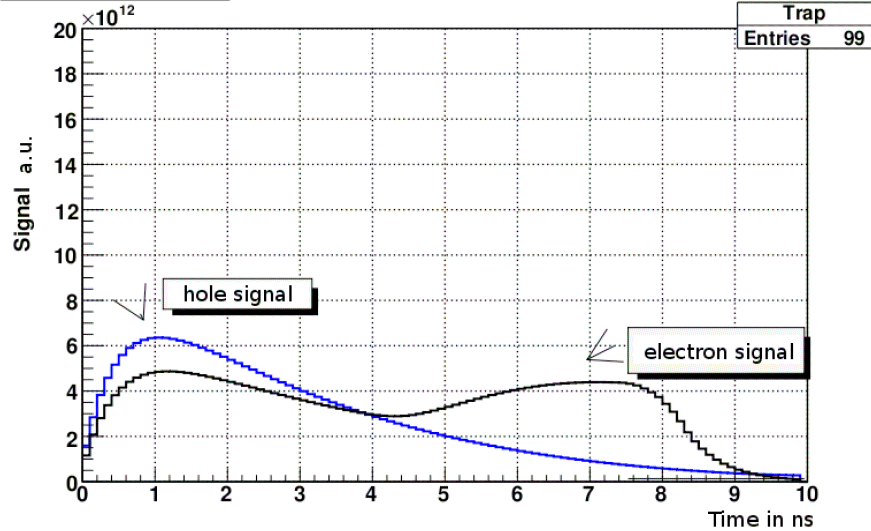


Double Peak Distribution

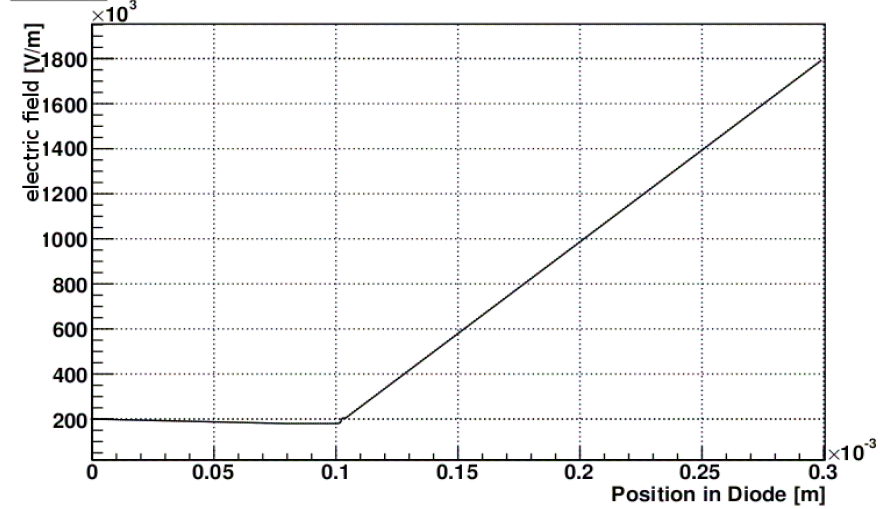


Changing the electric field, 200V

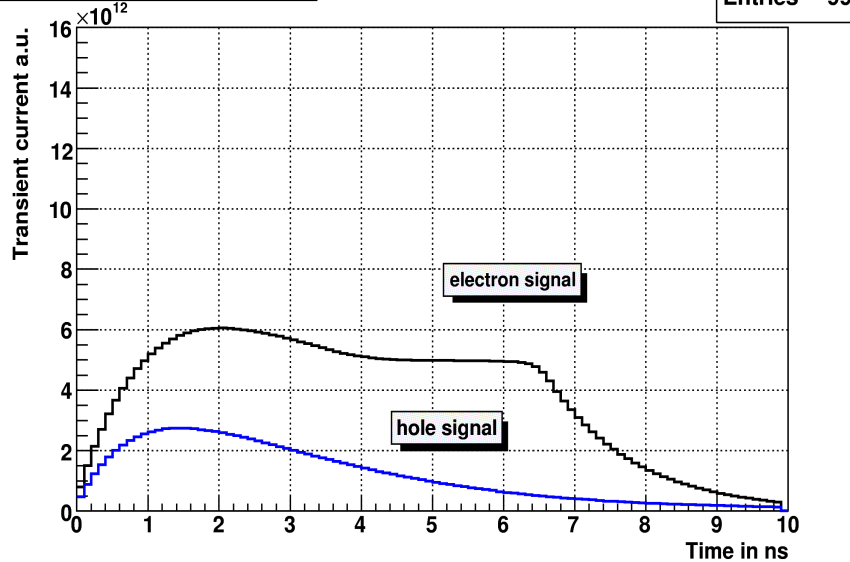
DP with Trapping



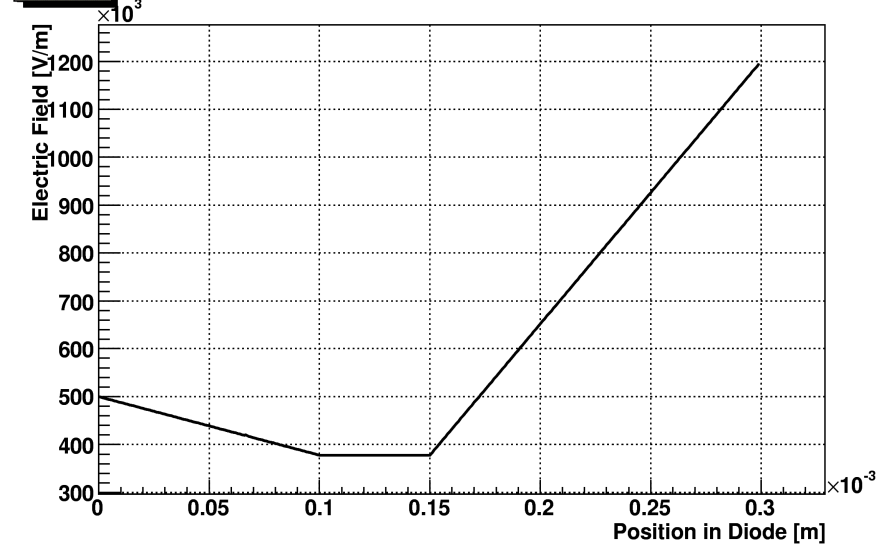
E-Field



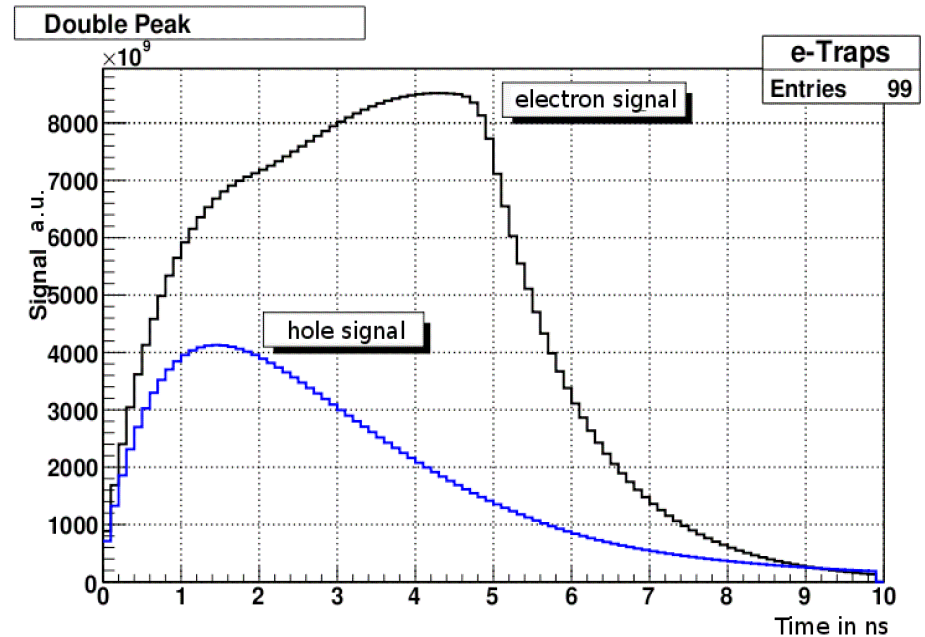
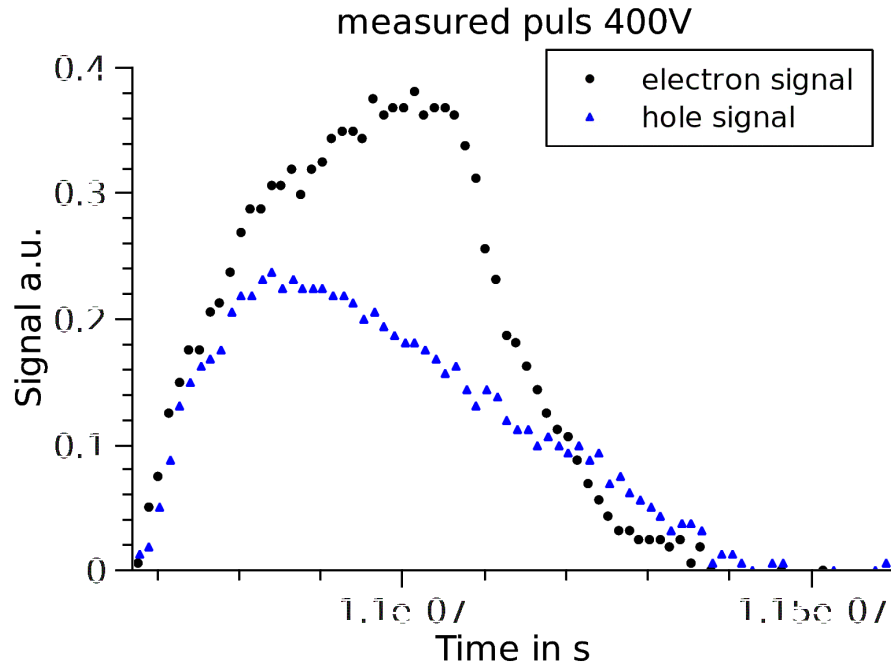
Double Peak Distribution



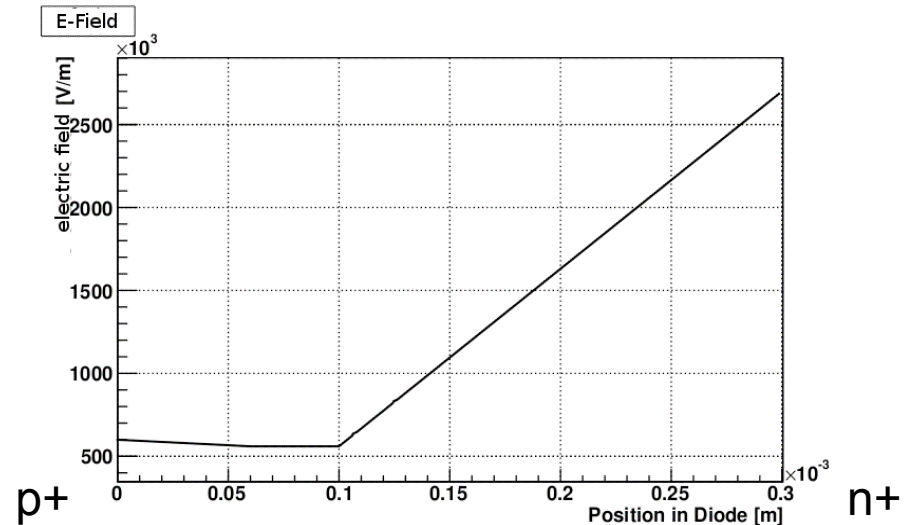
E-Field



Reconstruction of the electric field, 400V



- Simulated Signal longer than measured
- Diode might be thinner



- MCz diodes irradiated
- IV and CV measurements were made
- Trapping times determined for $F < 10^{15}$ n/cm²
- Continue measurements with annealing for more diodes
- Electric field simulated and reconstructed

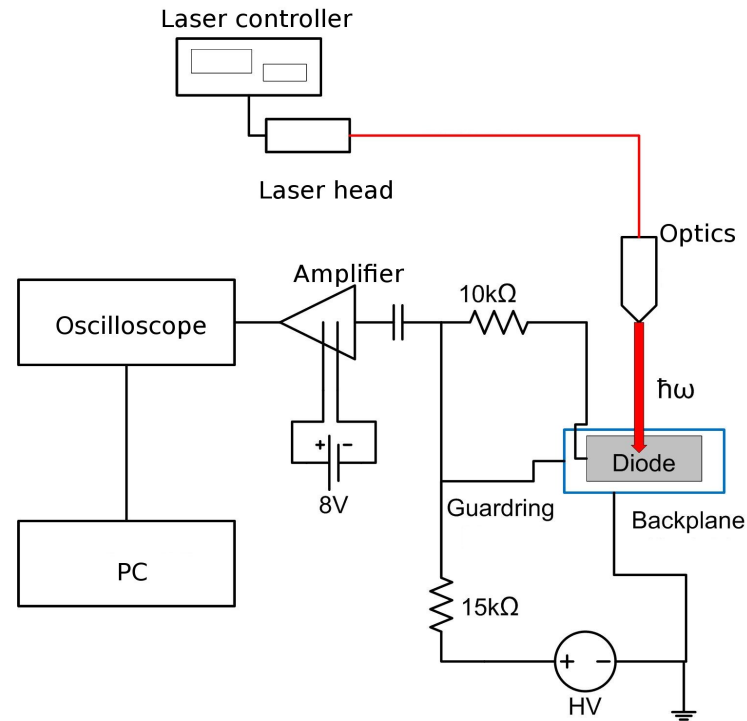
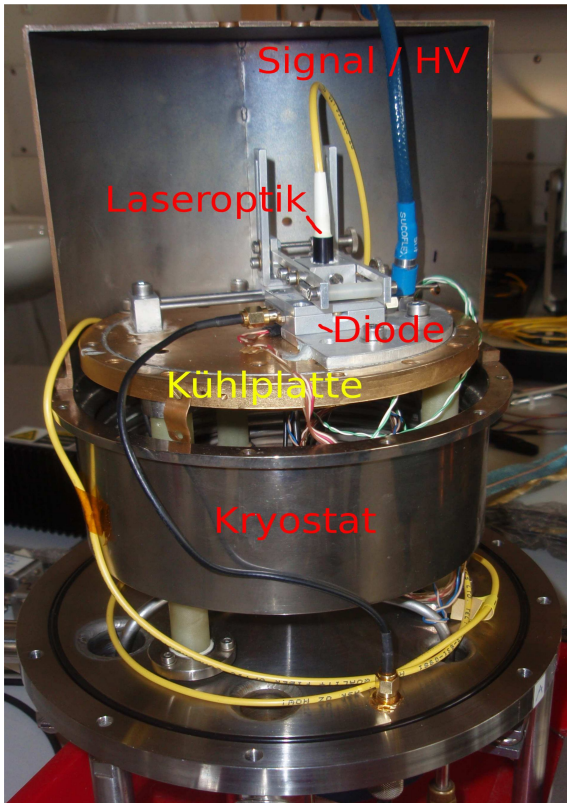
- MCz and FZ mini sensors irradiated like the diodes
- Mini sensors going to be tested in ALIBAVA

Thank You for Your Attention!

Any Questions?

Backup slides

Karlsruhe TCT Setup



- Laser: 678nm
- Temperature: -190°C to RT
- Voltage: 0V – +/-1100V

